

Our Docket No: 42P18458

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Gardner et al.

Application No: 10/749,986

Filed: December 31, 2003

For: Microring and Microdisk Resonators)
For Lasers Fabricated on Silicon)
Wafers)

Examiner: Dupuis, Derek L.

Art Unit: 2883

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 14, 2004, applicants respectfully request the Examiner to enter the following amendments and to consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

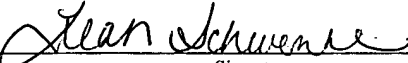
I hereby certify that I am causing the above-referenced correspondence to be deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and that this paper or fee has been addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

April 5, 2005

Date of Deposit

Leah Schwenke

Name of Person Mailing Correspondence


Signature

April 5, 2005

Date

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